

<b>Notice of References Cited</b>	Application/Control No. 09/748,504	Applicant(s)/Patent Under Reexamination HAYASHI ET AL.	
	Examiner Kim-Kwok CHU	Art Unit 2653	Page 1 of 1

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-6,055,216	04-2000	Shintani, Fumihiko	369/47.31
	B	US-			
	C	US-			
	D	US-			
	E	US-			
	F	US-			
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	J	US-			
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**FOREIGN PATENT DOCUMENTS**

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**NON-PATENT DOCUMENTS**

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